



icants:

P. LaCour et al.

Attorney Docket No.: MEGC116848

Application No.: 09/781,128

Group Art Unit: 2815

Filed:

February 9, 2001

Examiner: C.C. Chu

Title:

DATA MANAGEMENT METHOD FOR RETICLE/MASK WRITING

RESPONSE TO RESTRICTION REQUIREMENT AND AMENDMENT

Seattle, Washington 98101

May 19, 2003

TO THE COMMISSIONER FOR PATENTS:

INTRODUCTORY COMMENTS

In response to the Restriction Requirement mailed on March 18, 2003, applicants hereby elect Claims 1-14, 20, 22, 28 and 29 for prosecution. Claims 15-19, 21, 23 and 24-27 are withdrawn, subject to applicants' right to file one or more divisional applications directed to these features.

Please make the following amendments to the application.

05/23/2003 WASFAW1 00000084 09781128

168.00 OP 72.00 OP

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